



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Noriyoshi SATO et al.

Group Art Unit: 2891

Application No.: 10/539,569

Examiner: C. EVERHART

Filed: August 18, 2005

Docket No.: 124305

For: PLASMA GENERATOR, OZONE GENERATOR, SUBSTRATE PROCESSING
APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR
DEVICE

REQUEST FOR RECONSIDERATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the May 1, 2008 Office Action, the period for reply being extended by the
attached Petition for Extension of Time, please consider the following:

Remarks.